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E. R. Witt
Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/782,533 Confirmation No.: 3242
Applicants : An Shih et al.
Title : THIN FILM TRANSISTOR HAVING LDD
REGION AND PROCESS FOR PRODUCING
SAME
Filed : February 19, 2004
TC/A.U. : 2826
Examiner : Scott R. Wilson
Docket No. : 3304.2.120
Customer No. : 21552

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

This paper is submitted in response to the Restriction Requirement mailed June 3, 2005. Applicants elect the invention of Group I, claims 1-8, drawn to a thin film transistor display. If the Examiner requires any further information he is requested to contact the undersigned.

Respectfully submitted,

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Date: June 29, 2005

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